



△×				APPROVED	CHECKED	MATERIAL 材料	-	CHAMFER 一般面取	-	QUANTITY 個数
△×				T.A.	T.A.	TREATMENT 処理	-	FINISHING 仕上	-	-
△×						TREATMENT CONTACT 処理接点	-	DECENTRATION 偏芯	-	-
△×				DESIGNED	DRAWN	OVER 250 UP TO 1000	±0.3 ±0.5 ±1.0 ±0.2	ANGLE 角度	METHOD 図法	REMARK 適用 (機種名)
△×						OVER 63 UP TO 250	±0.2 ±0.3 ±0.6 ±0.15	UNIT (mm)	-	VS-TCM1-130/S
△× 1	Iris ring表記追加	19.03.03	T.F.	T.A.	S.K.	OVER 16 UP TO 63	±0.1 ±0.2 ±0.4 ±0.1	SCALE	1 / 1	DRAWING / 外觀図
NO. × 箇所	REVISION 訂正事項	DATE	NAME			OVER 0 UP TO 16	±0.05 ±0.1 ±0.2 ±0.1	DATE	'11.05.09	DRAW NO.
						TOLERANCES	A B C S			ODTTC0476A2